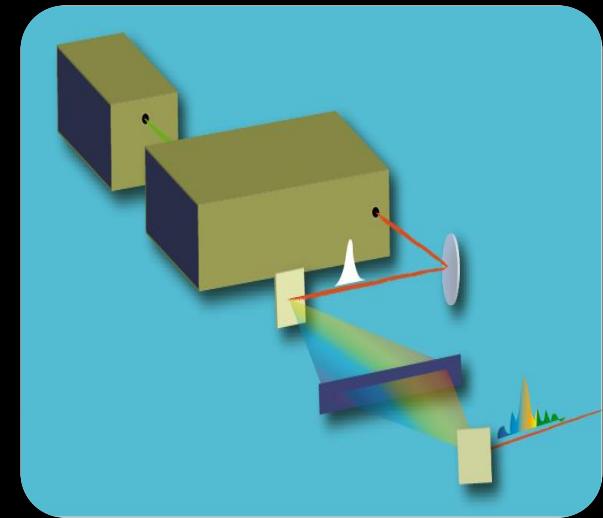
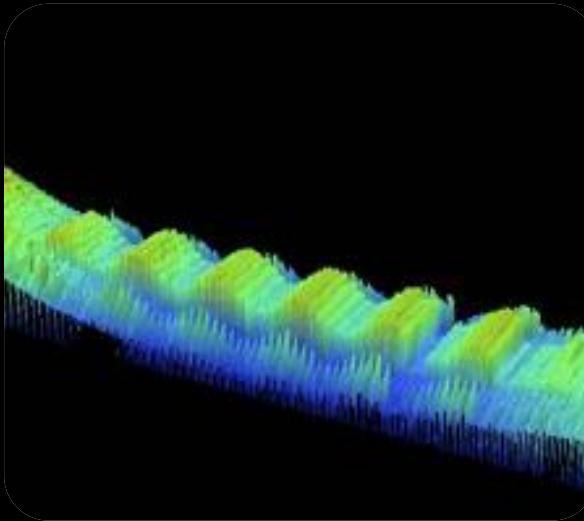
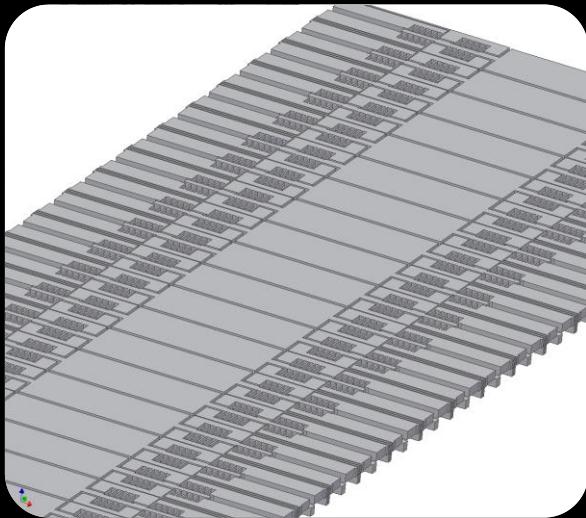


# *PuShME*: Spectral phase and amplitude modulation from DUV to IR with a reflective MEMS pulse shaper

*Luigi Bonacina*

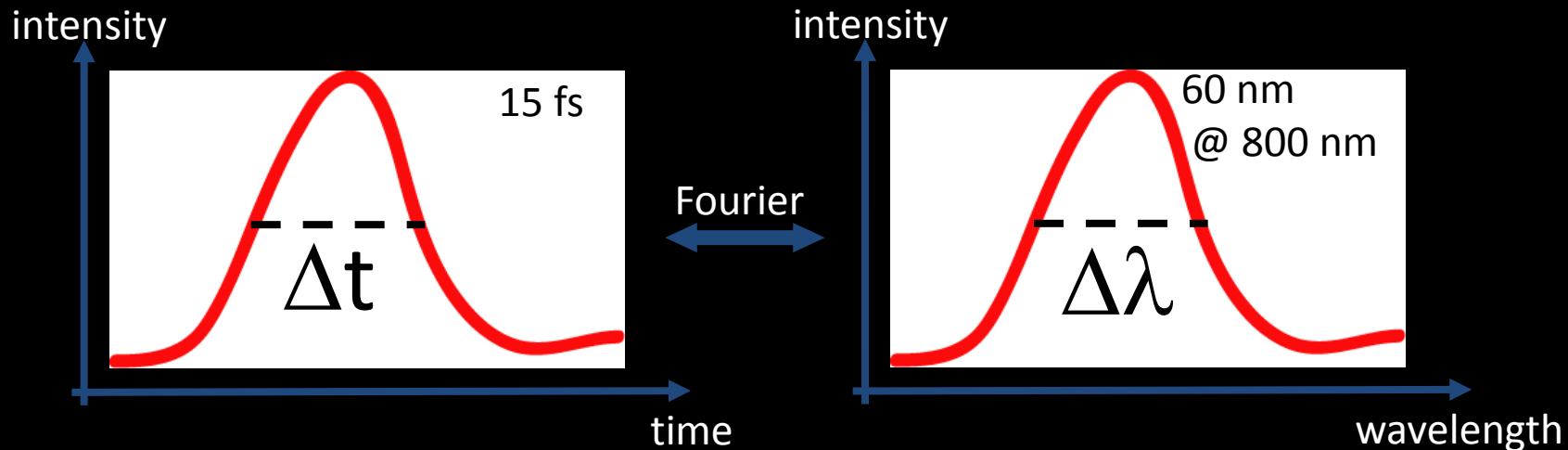
GAP Biophotonics – University of Geneva



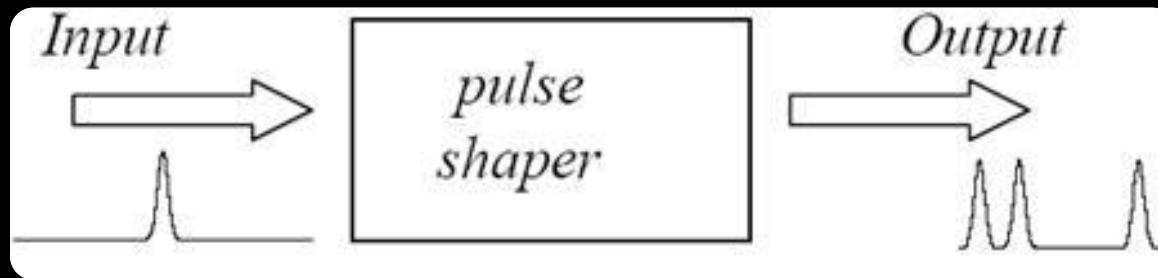
*SWISS\*PHOTONICS*  
2<sup>nd</sup> Photonic Instruments Workshop  
Technopark Zürich

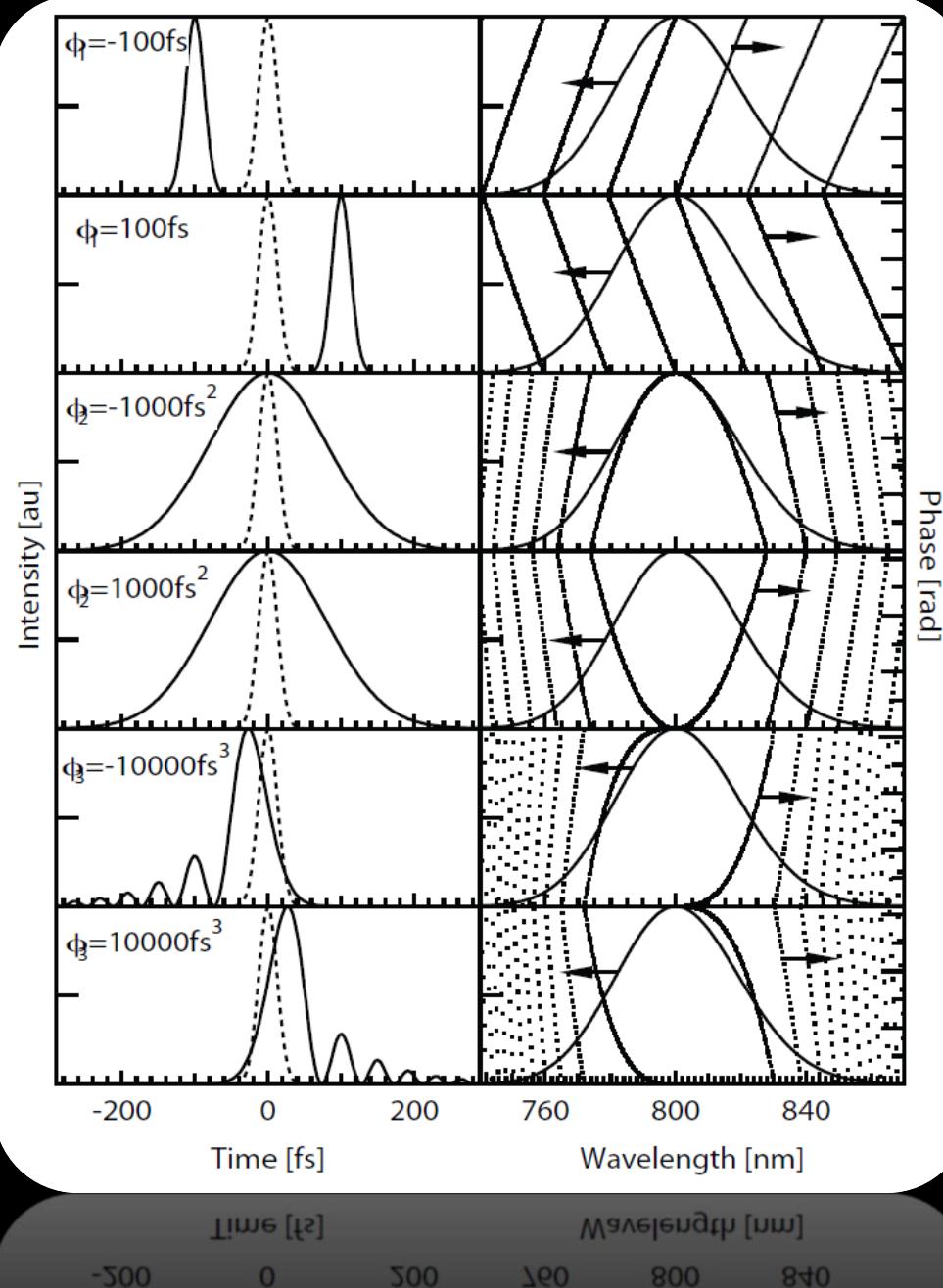
- Ultrashort pulse *temporal* shaping
- Current shaping techniques
- PuShME: a MEMS-based all reflective shaper
- Application examples

# Ultrashort laser pulses



- Time-bandwidth product  $\geq$  constant
- @ laser output: all spectral components in phase



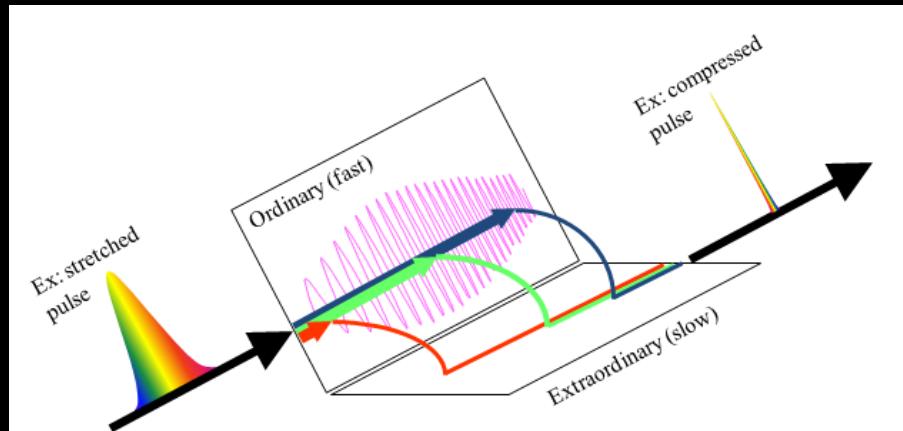


fs pulses are  
short...

→ shaping is  
performed in the  
spectral domain

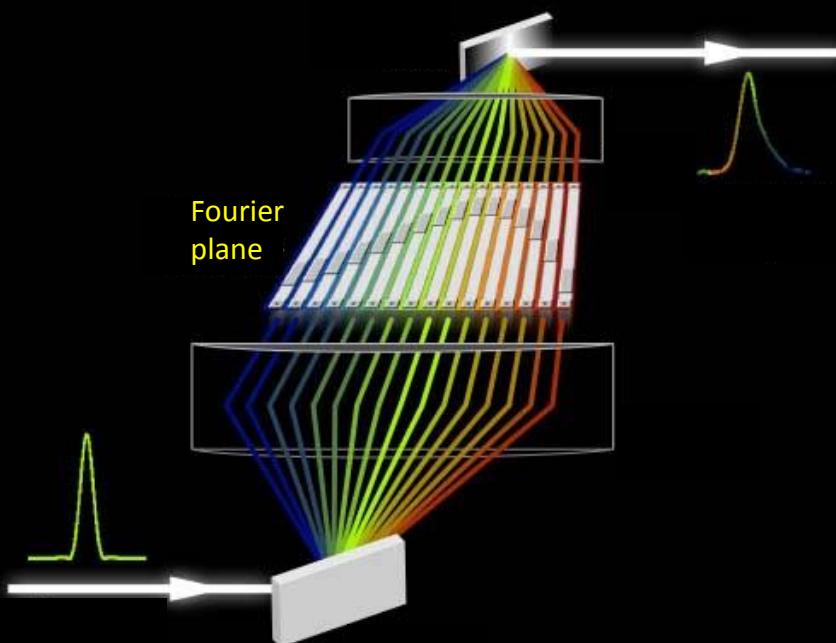
# Programmable pulse shapers

- Collinear:  
acousto-optic  
dispersive  
filter



Fastlite  
(*Dazzler*  
family)

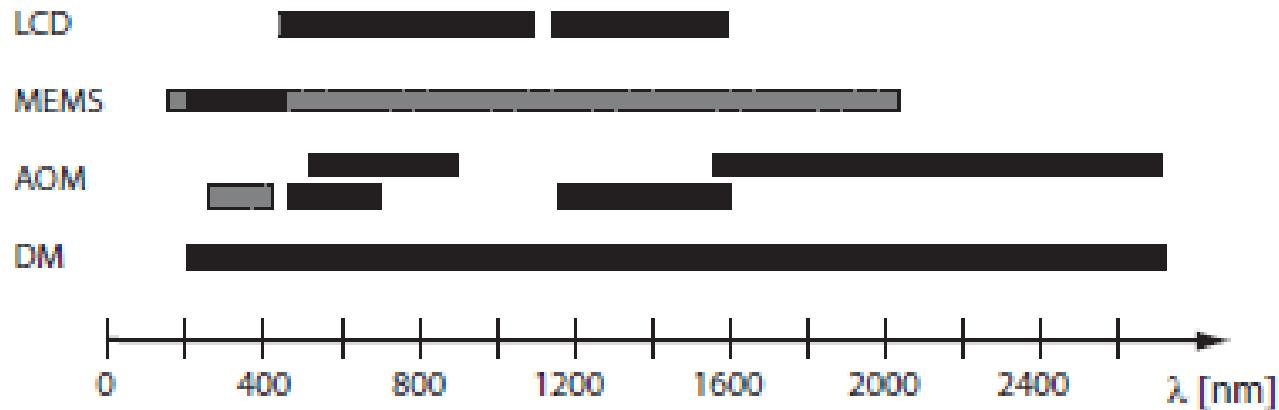
- Transverse:  
liquid crystal  
array in a zero-  
dispersion line



Jenoptik  
CRI  
Hamamatsu  
Holoeye  
...

# Programmable pulse shapers

## Specs



	Phase	Amplitude	Polarization	Indep. Parameters
LCD	■ ■	■ ■	■ ■	128, 640, 4096, 12288
MEMS	■ ■	■		100, 240
AOM	■ ■	■ ■		Several Hundreds
DM	■ ■			19, 38

DW

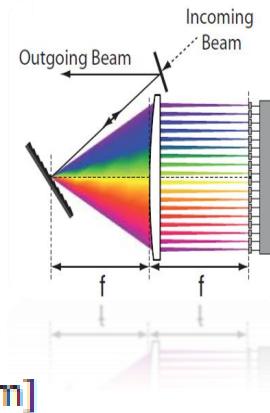
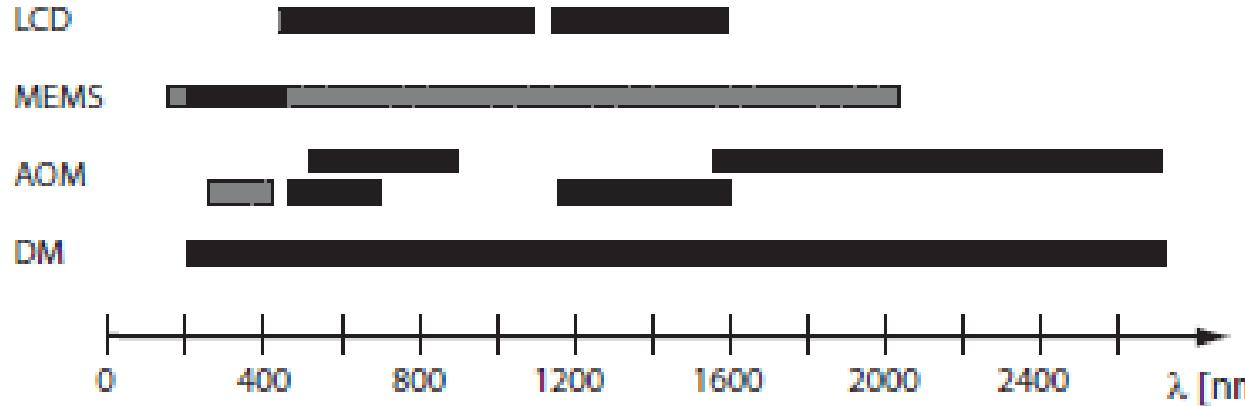
18, 61

MVA

several hundreds

# Programmable pulse shapers

## Specs



	Phase	Amplitude	Polarization	Indep. Parameters
LCD	■ ■	■ ■	■ ■	128, 640, 4096, 12288
MEMS	■ ■	■		100, 240
AOM	■ ■	■ ■		Several Hundreds
DM	■ ■			19, 38

Reflective: broad spectral bandwidth, high damage threshold

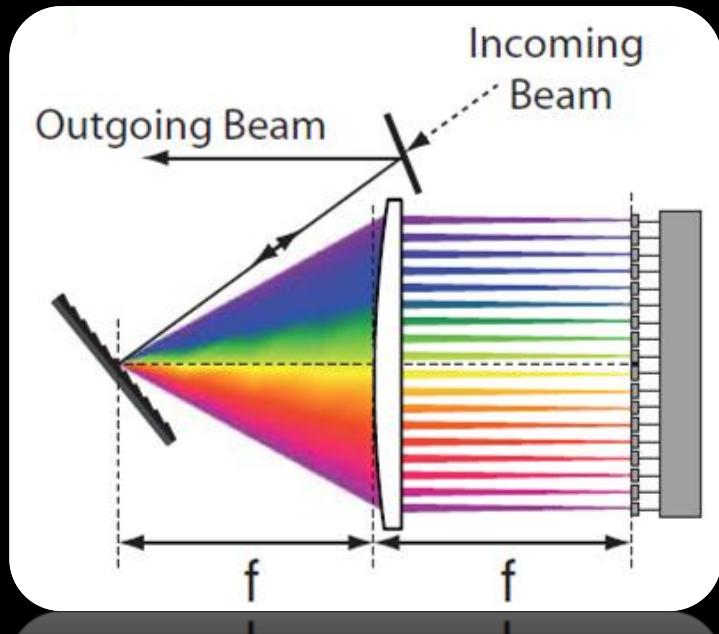
MVA

MVA

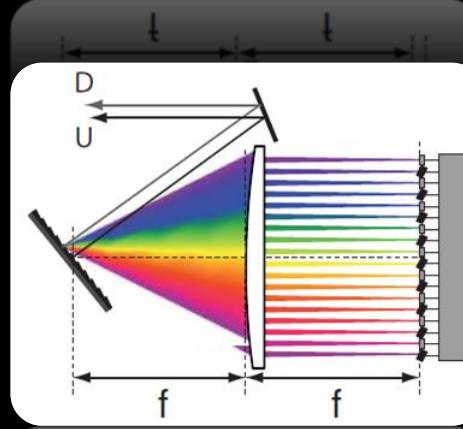
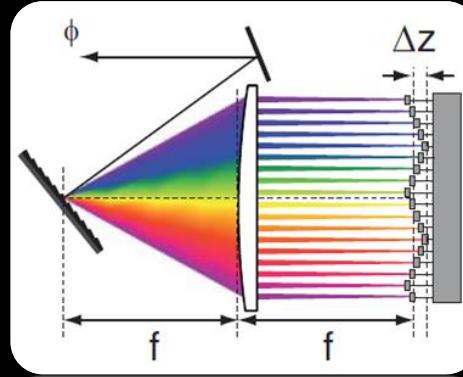
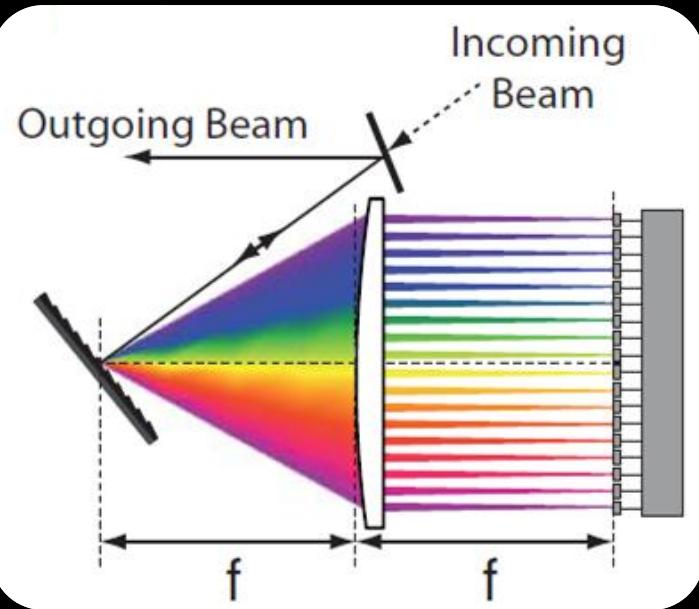
MVA

Scattered Light

# Reflective pulse shaping



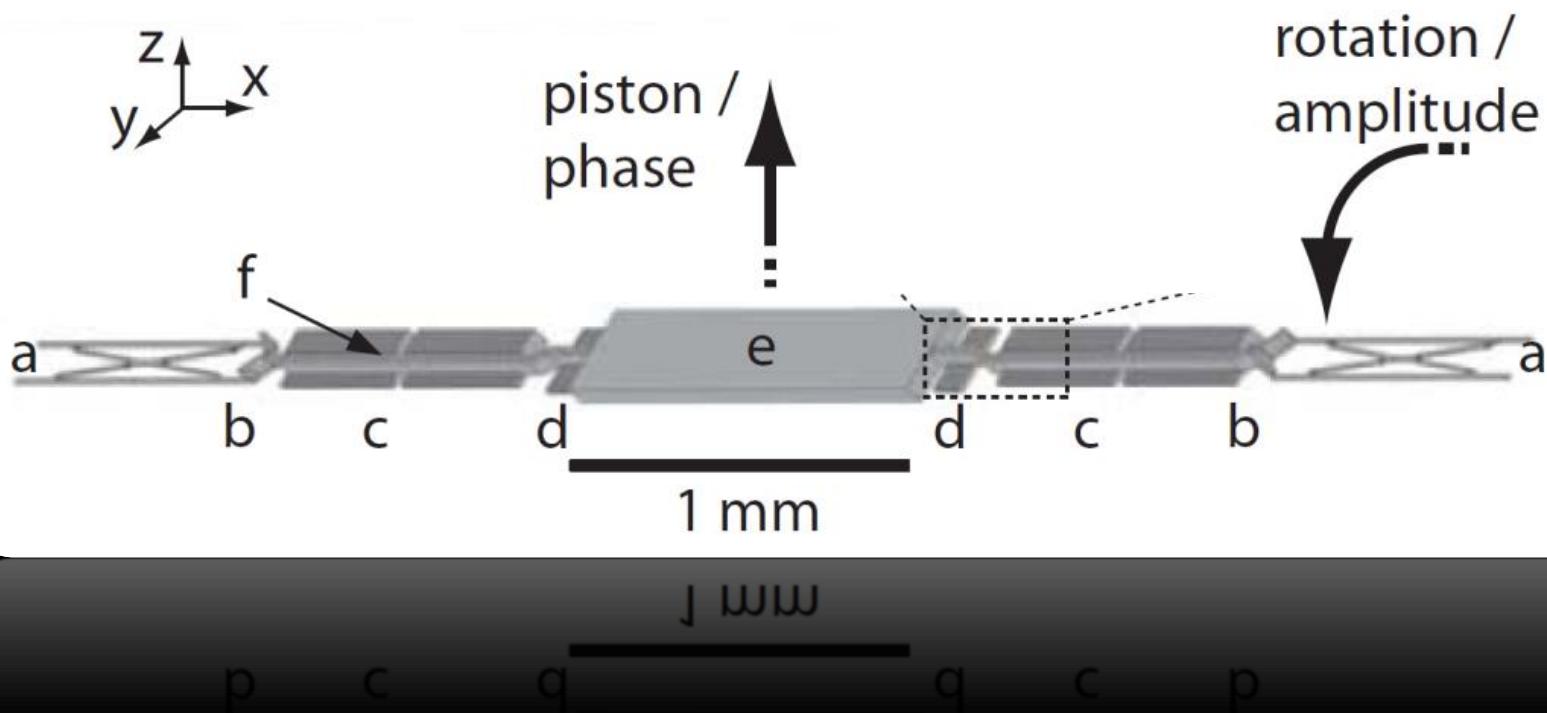
# Reflective pulse shaping



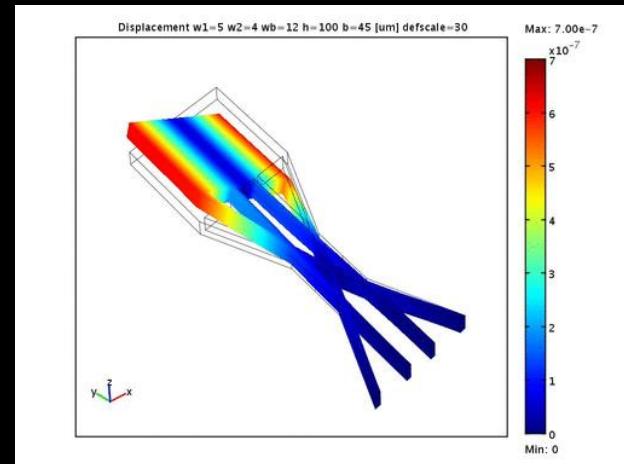
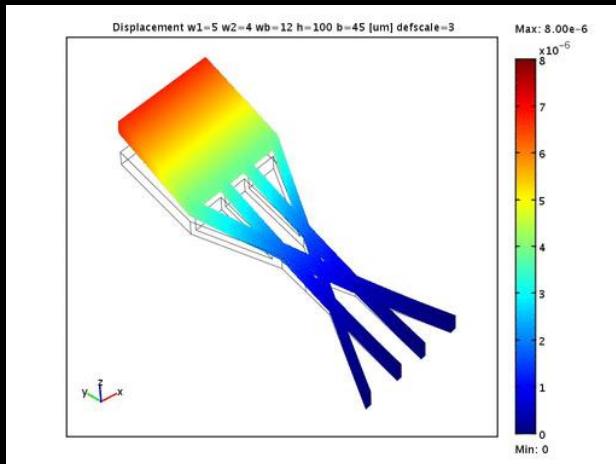
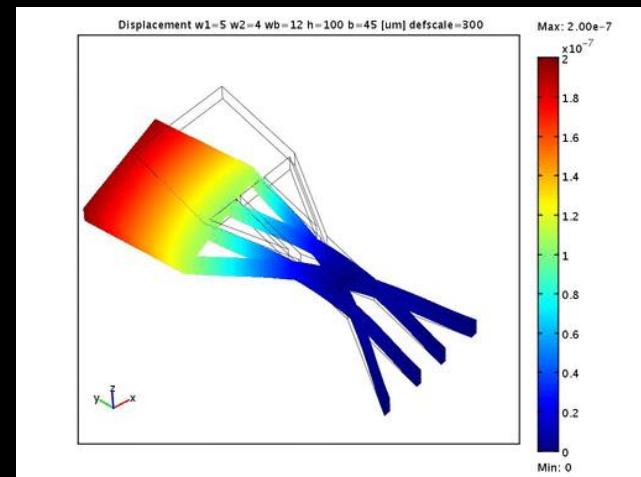
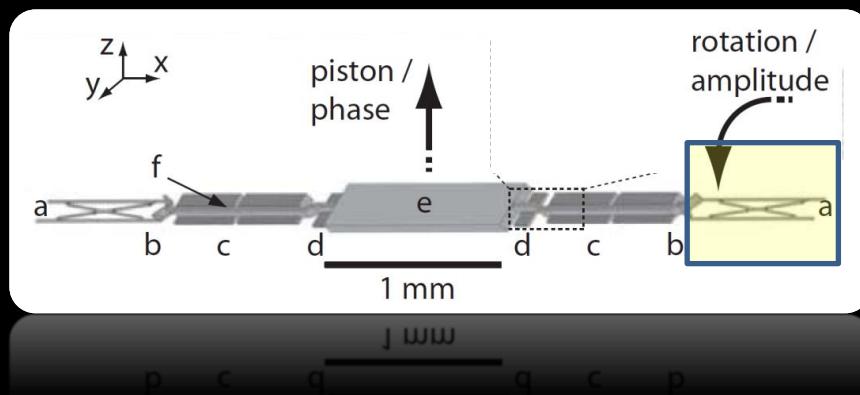
Phase  
modulation  
(piston)

Binary amplitude  
modulation  
(tilt)

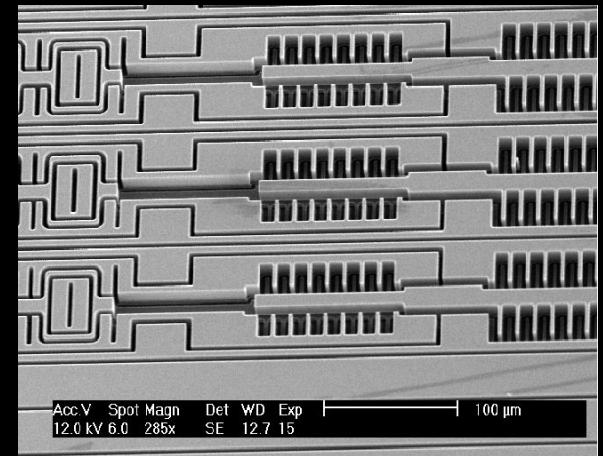
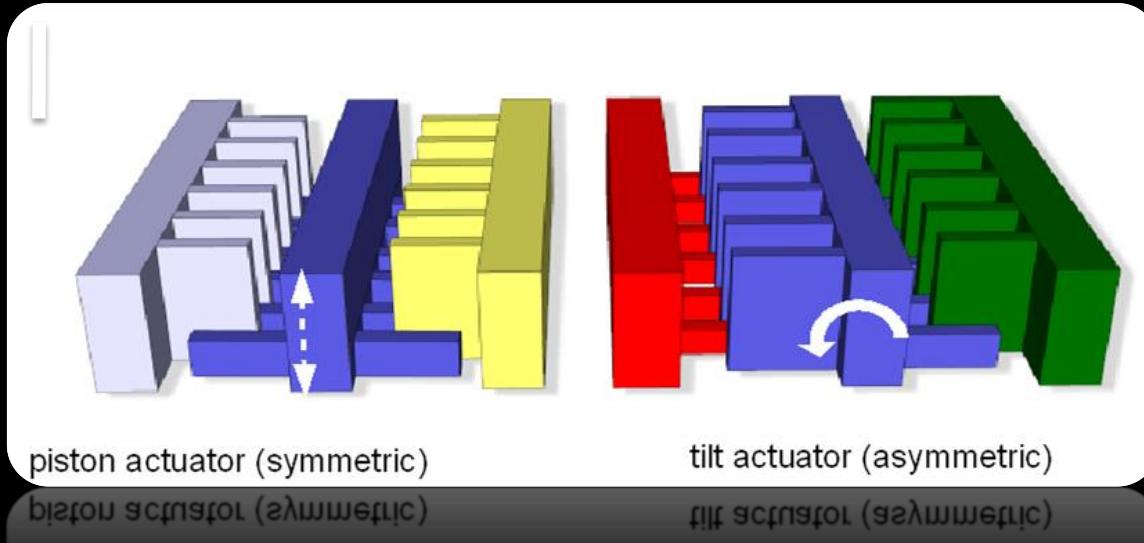
# PuShME technology: mirror element



# Parametric optimization of mechanical properties



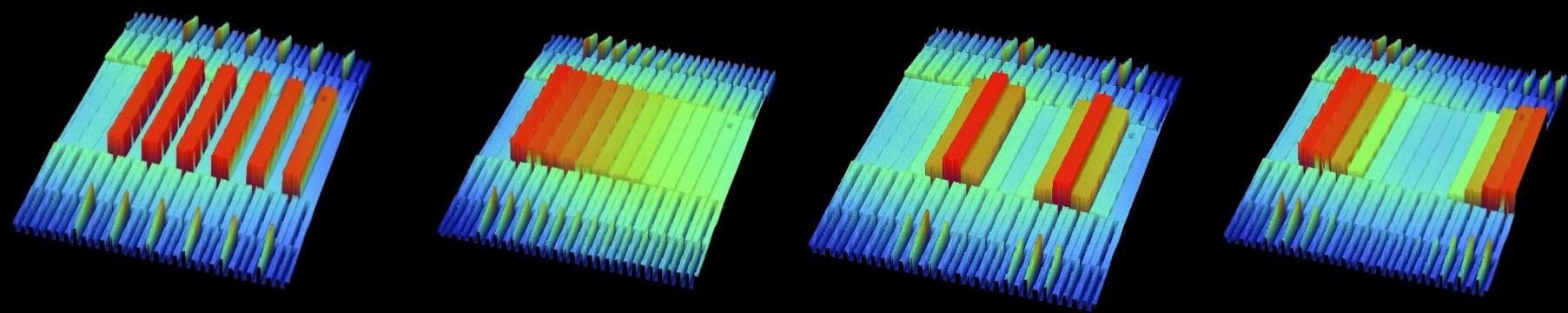
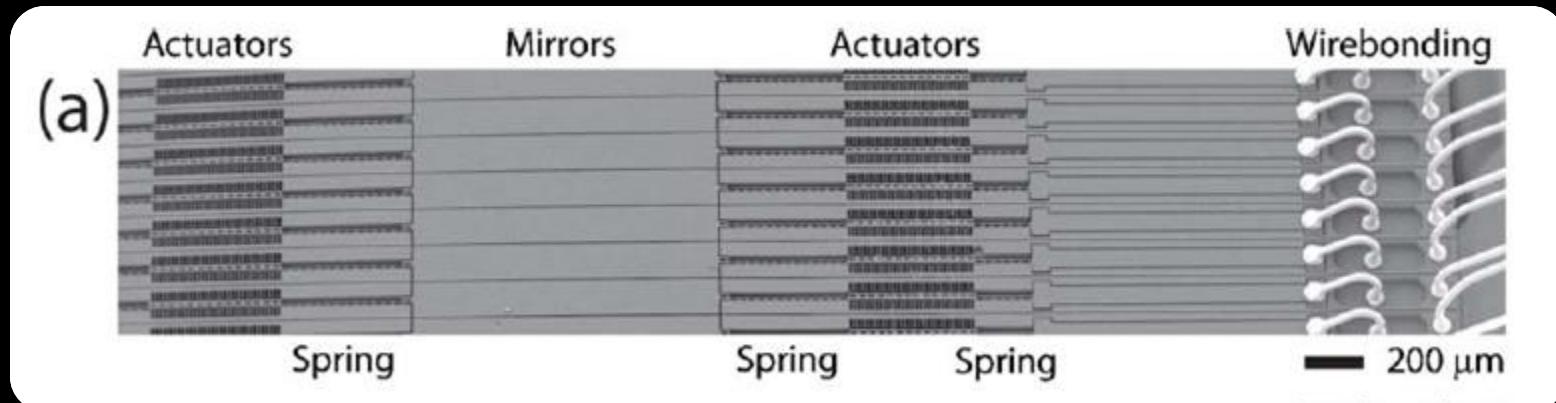
# Comb-Drive Actuators



Mirror movements → Coulombic repulsion between actuator and moving part

Resolution → limited by electronic encoding (and surface flatness)

# PuShME: Pulse Shaper MEMS



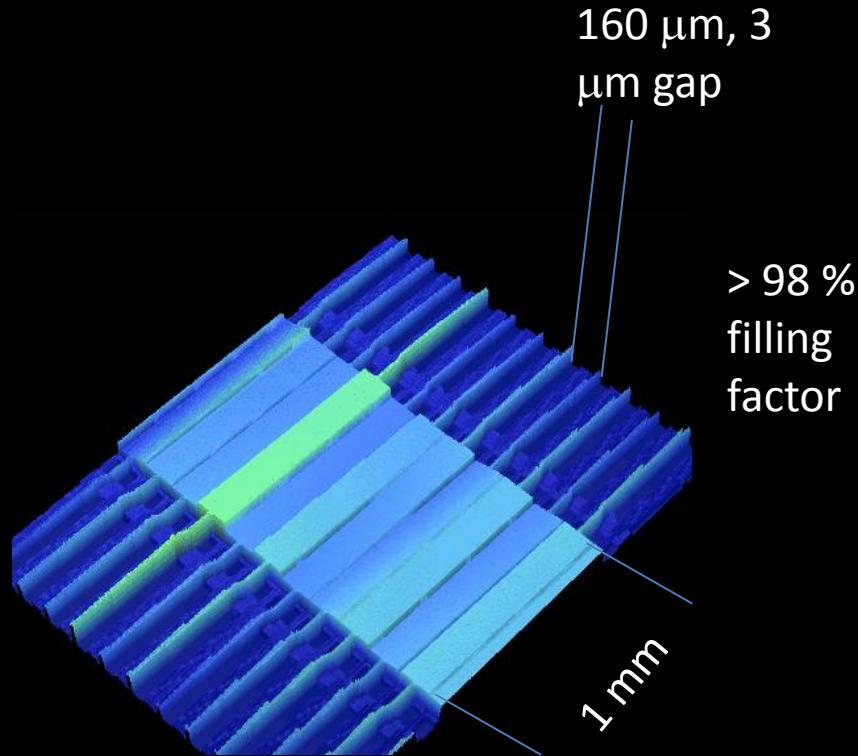
grating /  $\pi$  steps  
→ pulse sequence

linear ramp  
→ pulse shift in time

sine-modulation  
→ pulse sequence  
different  $\Delta t$

parabola  
→ pulse chirp  
management  
(i.e. compression)

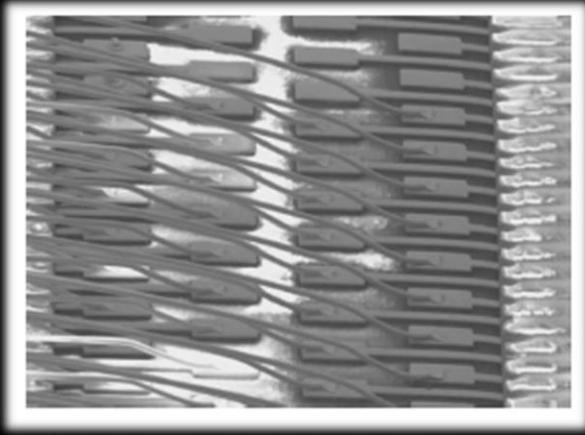
# Reflective pulse shaping



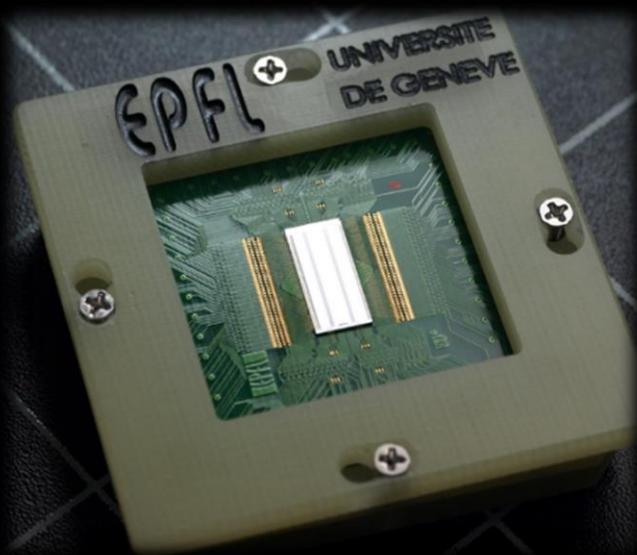
Damage threshold  
 $5 \times 10^8 \text{ W/cm}^2$   
@ 266 nm fs pulses  
Al coated

# Reflective pulse shaping

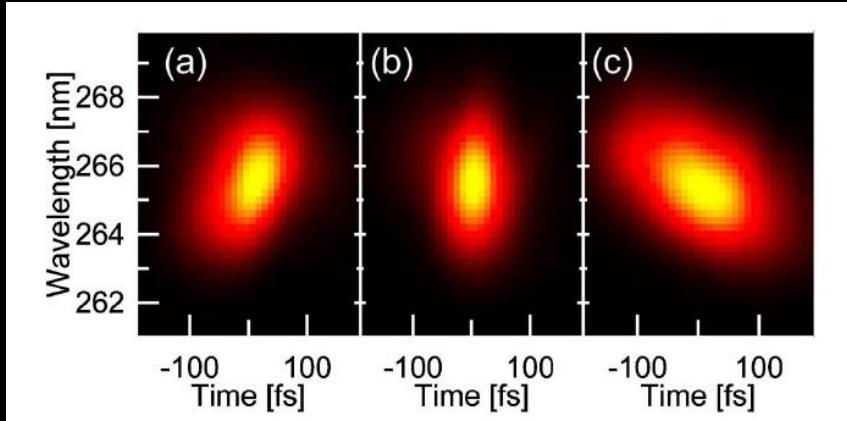
Four level wire-bonding



Assembled MEMS chip



*Review of scientific instruments*  
**82**, 075106 (2011)



PuShME successfully employed in the NIR, vis-UV, DUV, and XUV: *pulse compression, amplitude shaping, 1D spatial chirp control, coherent spectroscopy of bio-molecules, amplitude modulation of high harmonics* .

*APB* **111**(4), 541-549 (2013)

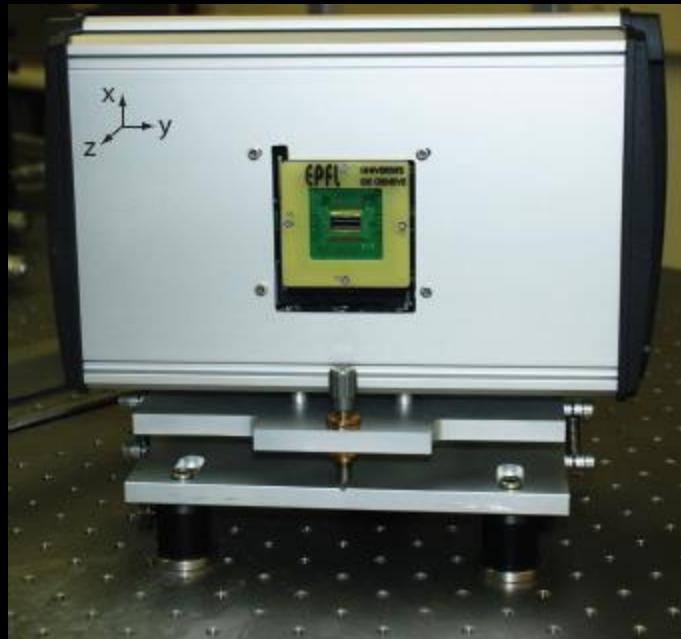
*PCCP* **14**, 9317 (2012)

*Rev. Sci. instr.* **82**, 075106 (2011)

*Opt. Express* **19**(8), 7580-7586 (2011)

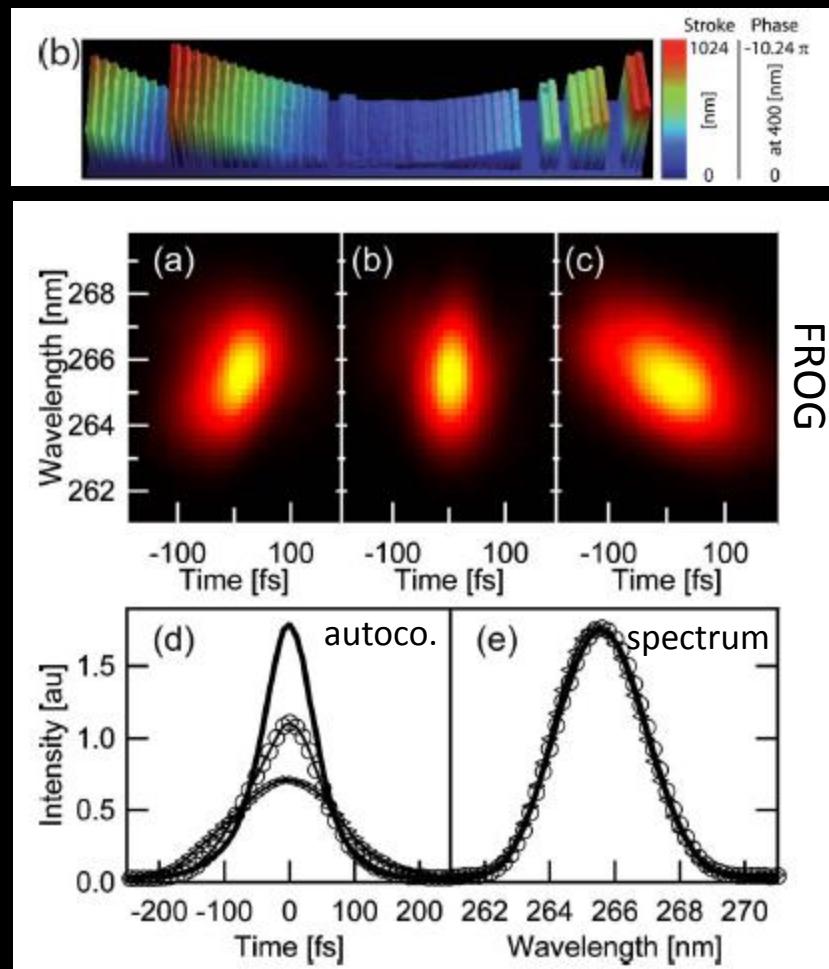
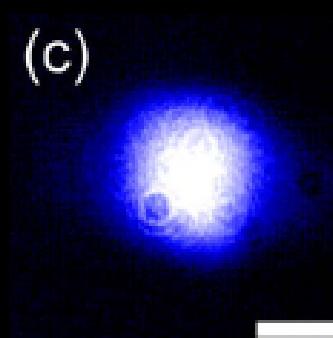
*Opt. Lett.* **35**, 3102-3104 (2010)

# PuShME: Phase-shaping

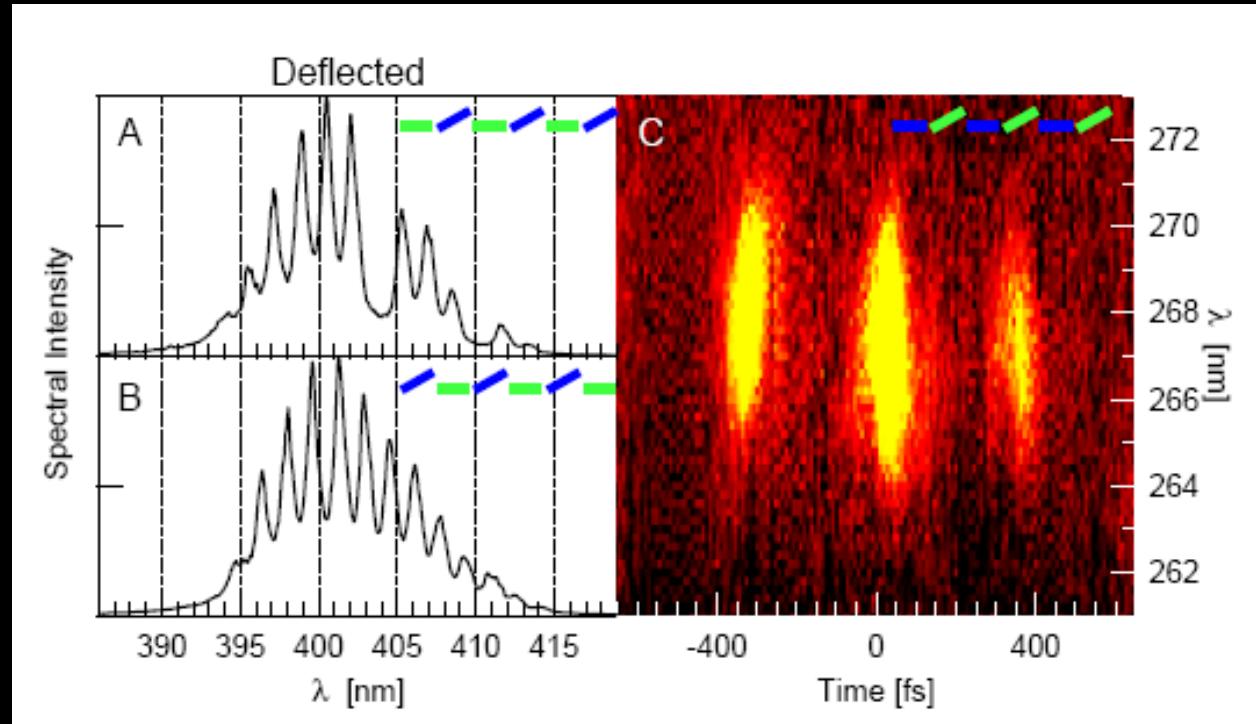
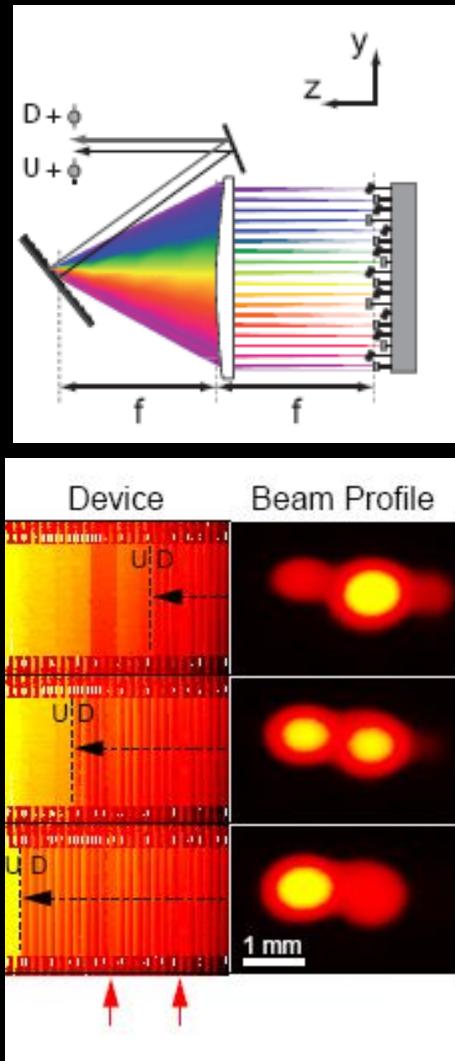


(c)

Shaped Beam  
profile (log  
colormap)



# Phase+amplitude-1D spatial-Shaping

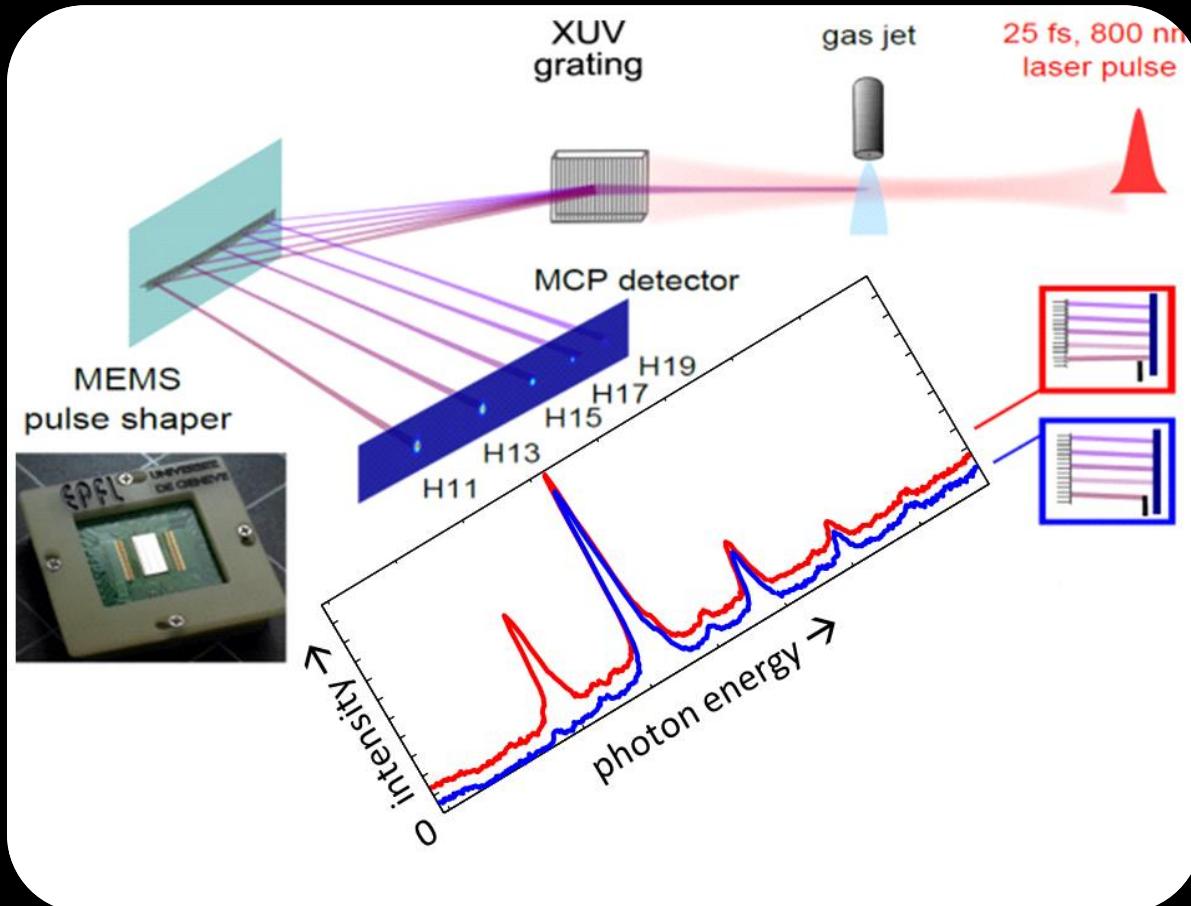


- Binary amplitude shaping
  - Double beam-phase shaping
  - Spatial shaping (spatial chirp, achromatic doubling, ...)

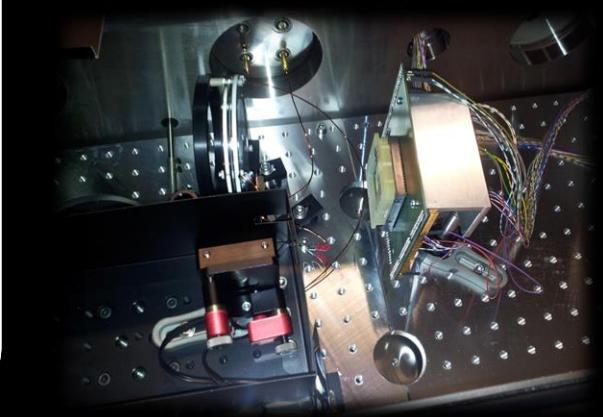
Weber *et al.* *Opt. Lett.* **35**, 3102-3104 (2010)

Weber *et al.* Rev. Sci. Instr., 82, 075106 (2011)

# Direct XUV –Pulse Shaping



In collaboration  
with  
H. J. Wörner lab  
*ETH Zürich*

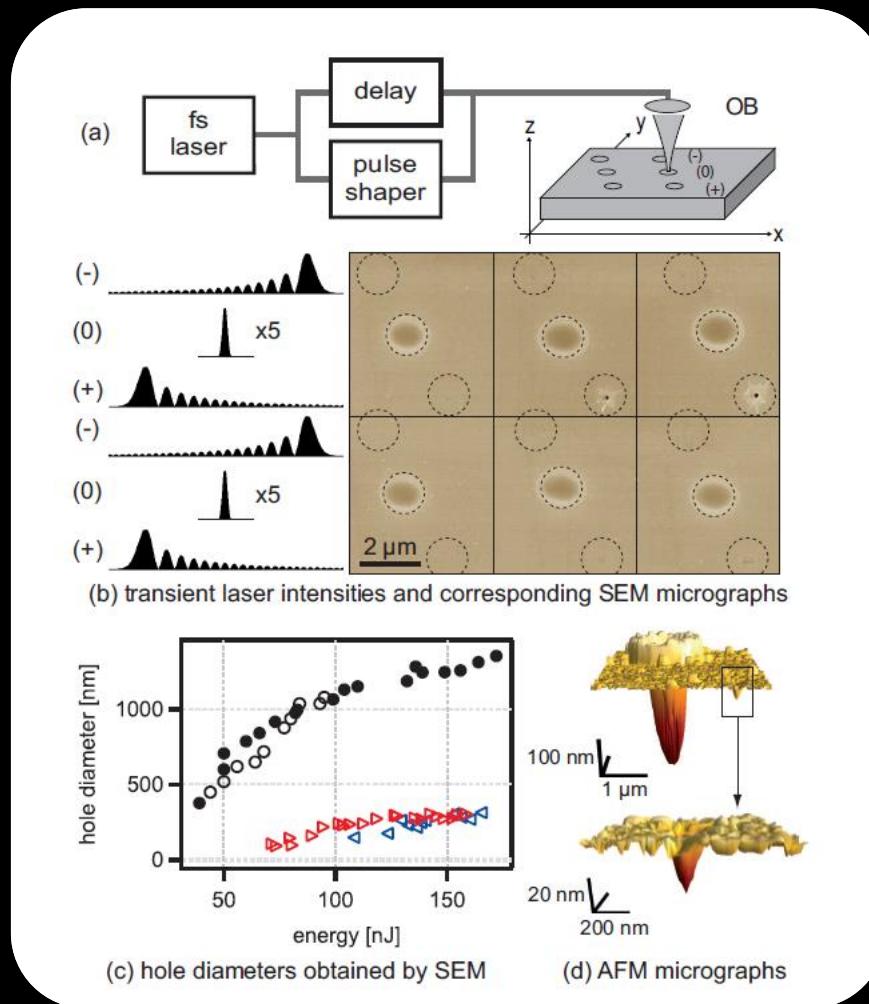


*OPTICS EXPRESS*, **20** (23), 25843-25849 (2012)



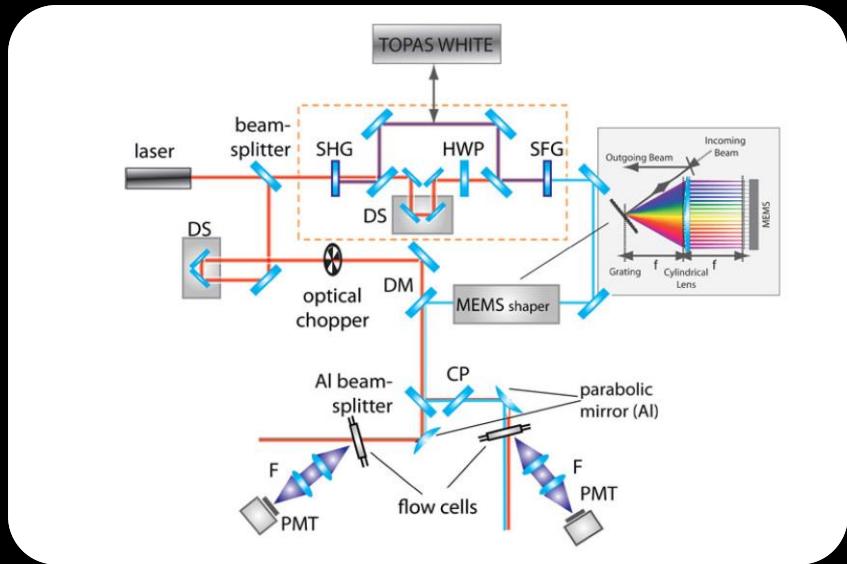
Molecular Ultrafast  
Science And Technology

# Micromachining

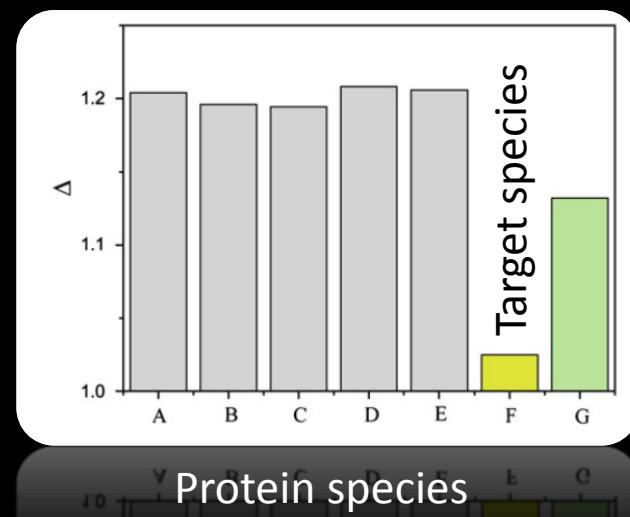


The control over pulse temporal structure can be used to optimize the aspect ratio of drilled holes in dielectrics

# DUV Coherent Immunoassays



The fluorescence response of selected bio-tracers in human serum is modulated by the phase shape of a DUV shape allowing their all optical identification



- 120 independent mirrors
- Phase + binary amplitude
- Large bandwidth  
**(XUV to IR)**
- High damage threshold





UNIVERSITÉ  
DE GENÈVE

## Optical design, electronics, measurements

*S. Weber\*, D. Kiselev, J. Extermann, M. Moret, L. Bonacina, J.-P. Wolf*

\* Now at Jenoptik



## Device mechanical design, MEMS fabrication

*Y. Petremand, W. Noell, F. Jutzi, S. Lani, N. F. de Rooij*



# Additional slides

# Spatial Chirp Control

